

Notice of References Cited	Application/Control No. 10/083,878	Applicant(s)/Patent Under Reexamination TU, XIANG ZHENG	
	Examiner Michelle R. Connelly-Cushwa	Art Unit 2874	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,163,635	12-2000	Helble, Robert	385/19
	C	US-6,408,120	06-2002	Dautartas, Mindaugas Fernand	385/52
	D	US-2002/0154854	10-2002	Tayebati et al.	385/18
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	J	US-			
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Toshiyoshi et al., "Electrostatic Micro Torsion Mirrors for an Optical Switch Matrix", Journal of Microelectromechanical Systems Vol. 5, No. 4, December 1996, pages 231-237.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.